



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 9, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG789613381

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.43 - 7.49 X 4.53 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.55 CARAT

E

VS 2

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

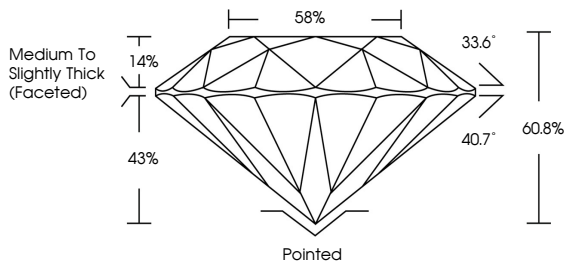
 LG789613381

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

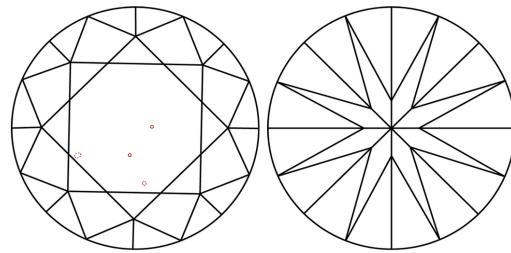
LG789613381

Report verification at [igi.org](#)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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ROUND BRILLIANT

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Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.55 CARAT

E

VS 2

IDEAL

60.8%

88%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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